

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.:	10/644,116	)	
		)	Conf. No.: 6516
Filed:	August 20, 2003	)	
		)	
Title:	<b>Whole-Wafer</b>	)	
	<b>Photoemission Analysis</b>	)	
		)	
Inventors:	Jeffrey Blackwood et al.	)	
		)	
Art Unit:	2624	)	
		)	
Examiner:	Daniel G. Mariam	)	
		)	
Atty. Ref:	03-0515	)	

**RESPONSE TO THE OFFICE ACTION MAILED NOVEMBER 6, 2006**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In the matter of the above-identified application and in response to the Office Action mailed November 6, 2006, kindly enter the following amendments and consider the following remarks toward reconsideration of the present application. A Petition for Extension of Time is enclosed, extending the deadline for responding to the Office Action to March 6, 2007.

Therefore, this Response is considered timely.